It's Time for 300mm Prime

Iddo Hadar

Managing Director, 300mm Prime Program Office

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Consumerization of Semiconductors



Consumerization of the Industry Changes Everything



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- Push for advanced technology created fab challenges:
 - High variability in tool operational performance (defects, MTBF, MTBI, MTTR)
 - Fabs incur high costs to contain and control variability
 - Fabs sacrifice cycle time to maintain operational efficiency
- This is NO LONGER ACCEPTABLE in the consumer era:
 - Cycle time / agility requirements
 - Cost
- Consumer era also severely curtails available funding across the semiconductor food chain

No more Business As Usual

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Fulfilling Moore's Law



Moore's Law Requires Continual Improvement in Cost/Function which Is Driven by Technology Innovations and Manufacturing

Ref: 2003 ITRS

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Economic Impact of Wafer Size Transition



Manufacturing Cost Trend



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Productivity Space





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300mm Investment May NEVER Be Repaid





<u>Assumptions:</u> Semiconductor industry trending from about \$200B at 8% p.a.; 300mm follows a 30-year life cycle, peaking at 50% of silicon area processed (implicitly assuming larger wafer generations); semiconductor companies enjoy 45% gross margin; 55% of semiconductor costs are in wafer fabrication; 30% of die costs can be reduced via 300mm adoption; initial investment is distributed evenly over a six-year period; cost of capital is 20%

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Equipment R&D Gap



Note: Affordable R/D forecast assumes 14% of equipment industry revenues Sources: S&P, SIA, SEMI, Infrastructure Advisors

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300mm Prime – What is it?

Any 300mm design that has the likelihood of being used in a 450mm environment

Examples: lot buffering strategy, carrier design, factory recipe management system, predictive maintenance strategy, etc.

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ISM's Vision

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ISMI Next Generation Factory Vision

- ISMI member company inputs: <u>50% reduction in cycle time and</u> <u>30% cost per area reduction</u>
 - Tool utilization, availability, and output remain high, continuing lower cost of tool ownership
 - Target: 50% reduction from today's cycle time values to offset continuing growth in number of mask layers and to reduce product delivery time to customers
 - Example: Today: 2 days → Future: 1 day per mask layer
 - One aggressive goal that has been stated is 0.7 days /mask layer
- Shorter cycle time enablers:
 - More reliable process equipment
 - Elimination of batching delays
 - Reduced lot sizes
 - Reduced raw process time
- Several factors must come together to realize substantially shorter cycle time
 - One of these factors is AMHS design
 - Likely smaller lot sizes and shorter cycle time will drive higher AMHS transport performance and storage requirements/strategies

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Source: ISMI, Scott Kramer, 11/6/2006

Fulfilling Moore's Law Via 300mm Prime





Moore's Law Requires Continual Improvement in Cost/Function which Is Driven by Technology Innovations and Manufacturing

Ref: 2003 ITRS

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Optimize fab operations



Build foundation of rapid, differentiated, technology solutions

- •Extend Litho
- •Enable transistor performance
- •Scale interconnect RC
- Scale memory density (strain)
- •Resolve nano defects

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300mm Prime: Maximizing the Return on 300mm Investment

- Definition:
 - The 300 mm Prime program seeks to implement <u>discontinuous</u> <u>improvements</u> in fab productivity of the type historically coinciding with wafer size transitions...
 - ... without incurring the costs and risks associated with a scale-up of tool sets
- Scope: primary focus will be increased fab <u>agility</u> and <u>reduced</u> <u>cycle time</u>, as a complement to <u>continuous improvements</u> in the productivity of the 300mm tool set
- Key levers:
 - − High-capacity, high-reliability material delivery system → small-lot manufacturing
 - "Intelligent" tools (high predictability)
 - Universal single-wafer processing

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Mapping 300mm Prime

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		Possible Technological Implementations (Example)			
Needs/Benefits/Levers		Small Carrier Size	Single Wafer Processing	Wafer Level Tracking	
First Wafer Effect	Average setup time				
	time to start processing 1 st wafer				
Tool Variability	% of down time that is unscheduled				
	Variability of time between down time				
	Variability of repair time				
Transport & Storage	Wafer wait time at tool inside carrier				
	Variability of carrier delivery time				
	Variability (distribution) of WIP awaiting tool				



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Consumerization of the Industry Changes Everything



- "Business as Usual..."
 - Sacrificing fab agility
 - Suboptimal (low-ROI) investment decisions
- ... is NO LONGER ACCEPTABLE in the consumer era
 - Cycle time / agility requirements
 - Resource limitations
- Fabs need to match the economics of the consumer era
 - Reconfigure tools to enable short cycle time manufacturing and short lead time
 - Small lot size
 - Frequent recipe change

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